

*IN THE UNITED STATES PATENT AND TRADEMARK OFFICE*

In re Patent application of :  
Won-suk Yang et al. : Group Art Unit: 2814  
Application No. 09/313,659 : Examiner: Kalam, Abul  
Filed May 18, 1999 : Confirmation No. 4199

METHOD FOR FABRICATING A SEMICONDUCTOR DEVICE

---

**REQUEST FOR P.T.O. ACTION**

U.S. Patent and Trademark Office

**E-FILING**

Randolph Building  
401 Dulany Street  
Alexandria, VA 22314

Sir:

Please advise the undersigned as to when issuance of a next action on the merits is expected in the above-identified application.

Respectfully submitted,  
VOLENTINE & WHITT, PLLC  
/Adam C. Volentine/

Adam C. Volentine  
Reg. No. 33289

**Customer No. 20987**  
One Freedom Square  
Suite 1260  
11951 Freedom Drive  
Reston, VA 20190  
Tel. (571) 283-0720

Date: March 23, 2009